



**ELECTRONIC COPY**

LG747569591  
Report verification at igi.org



November 18, 2025

IGI Report Number **LG747569591**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **7.85 - 7.93 X 4.75 MM**

**GRADING RESULTS**

Carat Weight **1.80 CARAT**

Color Grade **F**

Clarity Grade **VS 1**

Cut Grade **IDEAL**

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Color Grade **F**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

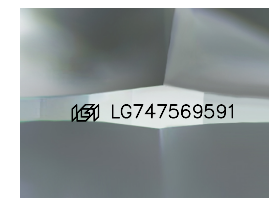
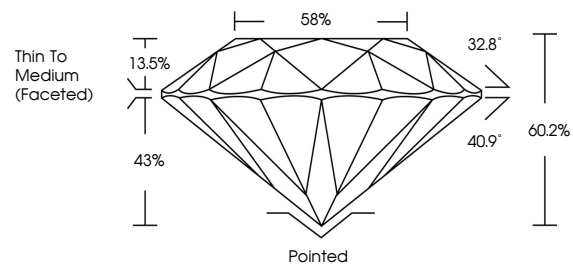
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG747569591**

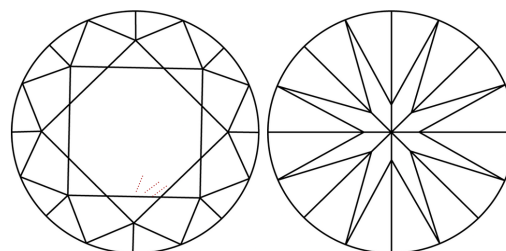
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

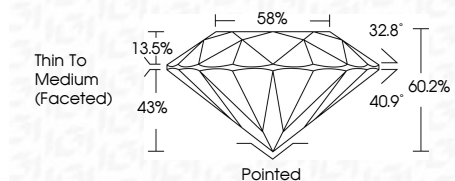
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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Symmetry **EXCELLENT**

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**IGI**



November 18, 2025	1.80 CARAT	F	VS 1	IDEAL	60.2%	58%	Thin To Medium (Faceted)	Pointed	EXCELLENT	EXCELLENT	NONE	IGI LG747569591
IGI Report No LG747569591	Carat Weight	Color Grade	Clarity Grade	Cut Grade	Depth	Table	Girdle	Culet	Polish	Symmetry	Fluorescence	Inscription(s)
ROUND BRILLIANT	7.85 - 7.93 X 4.75 MM											

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